

## **XY STACKED SYSTEM**

ASME-NNNN-02-0475-0410xx CHARON2HD XY with AccurET VHP

Data sheet

Version 1.0





## HIGH PRECISION POSITIONING STAGE

CHARON2HD XY
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ASME-NNNN-02-0475-0410xxXY STACKED SYSTEM

AXIS DESIGNATION				
Number of controlled axes  Axes name		2		
		X (bottom axis)	Y (top axis)	
Thrust transmitter: DD (direct drive) or ID (indirect d	rive)	DD	DD	
TESTING CONDITIONS	UNIT			
Position controller	-	VHP100 (10/30A)		
Motion controller	-	UltimET		
Rated payload	kg	7		
Rated input voltage	VDC	96		
Tool point position	mm	246.5 above bottom surface		
Ambient temperature	°C	22 ± 1		
Isolation system	-	QuiET		
DIMENSIONAL DATA	UNIT			
Width	mm	786		
Length	mm	948		
Height	mm	226		
Total stroke	mm	475	410	
Moving mass (without payload)	kg	26.6	6.40	
Total mass (without payload)	kg	55	5	
FORCE CARABILITIES (A)	10.07			
FORCE CAPABILITIES (1)	UNIT			
Peak force	N	991	681	
Continuous force	N	360	193	
Standstill force	N	272	145	
Max. detent force (average to peak)	N	26	16	
Static friction (maximal value)	N L	25	25	
Dynamic friction (maximal value)	N/(m/s)	25	25	
LOAD CAPACITIES	UNIT			
Maximum payload	kg	30		
DYNAMIC PERFORMANCE	UNIT			
Duty cycle	%	25	60	
Maximum speed	m/s	1.25	1.25	
Maximum acceleration	m/s <sup>2</sup>	20	20	
Typical position stability at 2 kHz	nm	±2	±2	
ACCUIDACV	LINUT			
ACCURACY	UNIT			
Positioning accuracy (without mapping)	μm	±20		
Positioning accuracy (with mapping)	μm	<u>±1</u>		
Bidirectional repeatability	μm	±0.4		
Horizontal straightness / radial runout	μm	±3	±3.5	
Vertical straightness / total axial error	μm	±2.5	±5	
Orthogonality Roll	arcsec	±15		
Roll Pitch	arcsec	±5	±10	
Yaw	arcsec	±5	±25	
I avv	arcsec	±10	±10	
WORKING ENVIRONMENT				
		ISO 2		
Clean room compatibility (2)	-	ISU	1 4	

ELECTRICAL SPECIFICATIONS (	1) UNIT	X (bottom axis)	Y (top axis)
Motor type	-	Ironcore	Ironcore
Motor model	_	LMS15-050-3TC	LMG10-050-3TB
Number of phases	_	3	3
Kt Force constant	N/Arms	45.4	26.8
Ku Back EMF constant (3)	Vrms/(m/s)	27.1	16.3
Km Motor constant	Nm/√W	45.5	28.2
R20 Electrical resistance at 20°C (3)	Ohm	0.663	0.605
L1 Electrical inductance (3)	mH	6.74	3.77
lp Peak current	Arms	30	30
Ic Continuous current	Arms	8.14	7.33
s Standstill current	Arms	6.17	5.55
ns Standstill speed	m/s	0.15	0.16
Um Max. input voltage	VDC	100	100
Pc Max. cont. power dissipation	W	74	56.3
<b>2τp</b> Magnetic period	mm	32	32
•			
ENCODER CHARACTERISTICS	UNIT		
Encoder and signal type	-	Optical - incremental	Optical - incremental
Output signal	-	1 Vpp	1 Vpp
Signal period or line count	μm	4	4
Reference mark	-	One	One
Power supply	V	5	5
VACUUM CHADACTERISTICS	LINIT		
VACUUM CHARACTERISTICS	UNIT		
Vacuum supply for wafer chuck	.	0.0	
Vacuum at interface output	bar	-0.6	
Vacuum supply for axis cleanliness		10	
Vacuum flow	l/min	10	6
TYPICAL MOVE AND SETTLE TIM	ES UNIT		
Move 1: 10 µm within ±100 nm window	ms	40	
Move 2: 25 mm within ±100 nm window	ms	130	
Move 3: 80 mm within ±100 nm window	ms	180	
GUIDING ELEMENTS			
Туре	-	Ball bearing	Ball bearing
MATERIAL AND FINISH			
Baseplate	_	Anodized aluminum	Aluminium & silicon alloy
Carriage	_	Aluminium & silicon alloy	Anodized aluminum
		, administra a smooth andy	, around didifficial
OPTIONS / ACCESSORIES / FEATU	RES		
Temperature sensors		Yes	No

According to the Machinery Directive 2006/42/EC, the system presently described falls into the "partly completed machinery" category and fully complies with it as long as the system is operated according to the working conditions described in the corresponding manual. Customer is responsible for setting safeties/limitations that will keep the motor in its safe operating area. ETEL cannot be held responsible if the system is used in an improper way.

Notes: The specifications given may be mutually exclusive. Unless stated otherwise, all measurements are made within the testing conditions.

- (1) Tolerances on electrical parameters are available on request.
- (2) Under vertical laminar flow conditions at 0.5 m/s . Measured at tool point level. Contact ETEL for more details.
- (3) Terminal to terminal.